

# ATF LASERS

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#### Nd:YAG LASER









LINAC

81 6 MHz

x 35

**RF GUN** 

#### Nd:YAG LASER





## **YAG Status - Overview**

- YAG system now in very mature mode of operation highly reliable, stable, flexible, and slowly improving.
- Since last users meeting, provided beam on 260 days and ~3000 hours. Average operating duration is >11 hours/day, which shows the usefulness of training experimental duty operators.
- Total shots since system was configured in its most recent form (ca. 1995) has now exceeded 100 million pulses!
- Upgrades ongoing, design of replacement underway.







# **YAG Status - Safety**

- Lab-wide stand-down issued Sept. 10, 2003
- ATF lasers first at BNL to be back online on Sept. 23
- All personnel retrained as per director's mandate
- All aspects of laser safety at ATF found to be in order: training, controls, eyewear, postings, and documentation met or exceeded requirements for restart
- Minimal operational impact to linac users!
- Laser experiments slower to receive restart approval





# **YAG Status - Demonstrated Performance**

See also:http://www.bnl.gov/atf/systems/lasers/NdYAG/YAG\_stats.htm

Energy: (dual pulse mode)	
UV on cathode	0-10 µJ
IR at CO2 table	5 mJ
Laser output: total IR	30 mJ
IR to gun	5 mJ / pulse
Green	1 mJ / pulse
UV	200 µJ
Repetition rate	1.5. 3 Hz
Pulse duration (FWHM):	
Oscillator IR	7 ps
Amplified IR	14 ps
Green	10 ps
UV	8 ps
Range of beam size on cathode ( $\emptyset$ )	0.2 - 3 mm
Top-Hat Beam Profile Modulation (P-P)	<20%
1	
Shot-to-shot stability (rms):	
Timing	<0.2 ps
Energy	2 %
Pointing (fraction of beam Ø)	<0.3%
Drift (8 hour P-P)	
Timing	<1ps
Energy	<15 %
Pointing (fraction of beam Ø)	<1%



Accelerator Test Facility

# YAG Status – CO<sub>2</sub> Slicing Improvements

- Measured second harmonic compression from 1 micron to 532 nm with pulse duration decreasing 3-4x in a 10 cm long KD\*P crystal.
- Energy available at 532 nm is  $\sim 100 \mu$ J, now limited by input energy.
- Multi-stage semiconductor slicing using both 1 micron & green pulses will allow few ps CO2 pulse generation for TW operation.
- New Pockels cell is on order to more efficiently utilize 1 micron energy between gun and CO2 slicing







# YAG Upgrades – Beam Profile



Some elements such as non-linear crystals and Pockels cells are not easily fabricated to such tight tolerances ( $<\lambda/20$ ).

Therefore it is very challenging to passively improve the uniformity of the beam.

200

50

100

150

200

250

300

350

400

450

500

550

600

Uniformity of electron emission from photocathode affects emittance.

Laser uniformity is limited by phase errors in optical elements that are transferred to the intensity domain as the beam propagates to the photocathode.



### **YAG Upgrades - Active Profile Shaping**

•A micromirror array consisting of a 1024x768 grid of 13 micron square mirrors is commercially available.

•Mirrors can be controlled individually to one of two tilt states. A group of mirrors smaller than the resolution limit of the laser transport optics provides discrete control of intensity at on point in the beam profile.

•The large number of mirrors will allow both high resolution and ~ 100:1 dynamic range in intensity over the entire beam profile. This should allow beam uniformity to be adjusted to within 1%.

•Sample arrays have been tested with the ATF laser and meet the requirements for damage threshold and reflectance control.

•A development version with computer control is on order for further testing.





# Future Prospects – Advanced Drive Laser Design

#### **GOALS:**

- 100 uJ available UV on cathode (currently ~ 10-20 uJ)
- Energy jitter 0.2% rms ~ 1% p-p (currently ~ 1% rms)
- Timing jitter < 200 fs rms
- Profile uniformity ≤ 5% p-p from desired arbitrary profile (currently ~20%)
- Pointing Jitter ≤ 1% p-p (currently < 0.3%)
- Retain desirable characteristics of current system:
  - Fast turn-on
  - High Reliability
  - Simple operation (~turn-key)



#### **APPROACH:**

- Rely on diode pumping
- Choose efficient 1 µm materials (e.g. Ytterbium:glass Yb:S-FAP)
- Integrate high-level commercial components in-house
- Provide capability for optical synchronization of facility by seeding additional amplifiers
- Design system as a photocathode driver from the beginning!



# ATF user's experiments with CO<sub>2</sub> laser completed experiments:

- Inverse Cherenkov Accelerator
- IFEL Accelerator
- Staged Electron Laser Accelerator (STELLA I and II)
- High Gain Harmonic Generation (FEL)

# currently active experiments:

- Compton Scattering of ps Electron and CO<sub>2</sub> Beams
- Laser Driven Cyclotron Autoresonance Accelerator (LACARA)
- Structure-based Laser Driven Acceleration in Vacuum

# more to come





#### CO<sub>2</sub> laser status and perspectives

•Until recently, operated at the 180 ps 30 GW level. The relatively long pulse duration was due to a narrow bandwidth of a preamplifier.

•Advisory panel (September 2001) outlined practical steps to attain ~1 TW primarily by shortening pulse duration:

Generation of ~3 ps SH of YAG laser in a KD\*P crystal

Gate ~3 ps  $CO_2$  pulse with a fast semiconductor or Kerr switch controlled by YAG SH

Acquire 10-atm preamplifier

•Presently, all these hardware upgrades are completed and integrated into the system that operates at 30 ps 0.5 TW (to be confirmed).

•We will proceed with a gradual improvements leading to a shorter pulse and higher peak power by optimizing the YAG and  $CO_2$  setup.





# High-Pressure CO<sub>2</sub> Amplifiers







# Final CO<sub>2</sub> amplifier is upgraded with adding extra 2 passes (6 total) and external mirror adjustment





# After upgrade the ATF CO<sub>2</sub> laser system will be capable to 1 TW peak power

Principle of Semiconductor Optical Switching







#### On-line diagnostics



#### Demonstrated and prospective $CO_2$ laser performance

	preamplifier	final amplifier
Pulse length	30-180 ps	(3ps)
Energy	10 mJ	15 J
Repetition rate	1 Hz	1 / 20 Hz (limited by power supply)
Peak power	1 GW	0.5 TW (>1 TW)
Focal spot (σ)		<mark>32 μm  (~10 μm)</mark>
Laser strength (a)		0.1 (>2)
Beam size (on transport mirrors)		50 mm







#### We send 2" dia laser beam to Experiment hall



## 6-foot motorized optical delay stage and

another universal laser/e-beam interaction cell to be installed in beamline #2 will facilitate and speed up installation of new experiments





# $CO_2$ laser has been channeled in capillary discharge





This enables a new generation of experiments on laser/e-beam interaction in plasma







free space







#### Summary on CO<sub>2</sub> laser progress and new developments since the last User's meeting and the next plan

•Recent hardware upgrades (new 10-atm preamplifier, 3 ps YAG SH) allow a short-pulse Terawatt regime. Presently, the system operates at 15 J with the pulse adjustable between 30-180 ps.

We will proceed with the system optimization towards a shorter laser pulse and higher peak power.

Demonstrated laser channeling in plasma expands the ATF capabilities opening a new class of User's experiments .

Improved e-beam/laser synchronization tune, universal interaction cell, and an extra site for interaction experiments are getting available to users.

## CO<sub>2</sub> output beam optics





#### SH compression in KD\*P crystal

Starting with the existing long pulses (14 ps) from the ATF YAG laser, second-harmonic compression\* can be used to generate ps to sub-ps green pulses.



\*Y. Wang, and R. Dragila, Phys. Rev. A 41, 5645 (1990)



# SNLO code simulations of 1064 to 532 nm conversion in 10 cm crystal with group velocity



•Measured compression from 1 micron to 532 nm with pulse duration decrease of 3-4x in a 10 cm KD\*P doubler.

•Energy available at 532 nm is ~ 100 mJ, now limited by input energy.

•New Pockels cell is on order to more efficiently utilize 1 micron energy between gun and CO2 slicing.

•Multi-stage semiconductor slicing using both 1 micron & green pulses will allow few ps CO2 pulse generation for TW operation.



#### Single shot autocorrelator

